

**Search Notes**

Application/Control No.

10/699,306

Examiner

Dru M. Parries

Applicant(s)/Patent under  
Reexamination

YOON, BYEONG KI

Art Unit

2836

**SEARCHED**

Class	Subclass	Date	Examiner
307	116	2/11/2006	DMP

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
Interference search conducted		12/15/2006	DMP

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST search notes attached (REVISED)	12/15/2006	DMP